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_FEB 13 2006

Attorney Docket No. 02W234

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

: Date: February 10, 2006

Mary Morabito O'Neill

Appln. No. 10/615,133

: GAU: 3641

Date filed: 07/08/2003

For: Obscuration Method for

: Examiner: Troy Chambers

Reducing the Infrared Signature of :

an Object

: Confirmation No. 8119

STATEMENT OF THE SUBSTANCE OF INTERVIEW

Via facsimile 703-872-9306

Commissioner for Patents PO Box 1450 Alexandria VA 22313-1450

Dear Sir:

Pursuant to the Interview Summary, PTOL-413, dated January 31, 2006, in this case, Applicant is required to file a Statement of the Substance of the Interview. Applicant agrees with the Interview Summary dated January 31, 2006, filed by the Examiner in this case.

During the telephonic interview of January 23, 2006, all of the claims were discussed with respect to the restriction requirement, although no claims were discussed with respect to prior art or any rejection. A brief identification of the general thrust presented to the

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, PO Box 1450, Alexandria VA 22313 on the date shown below:

Typed name: William C. Schubert

Group Art Unit 3641
Appln. No. 10/615,133
Statement of the Substance of Interview

Examiner was that at least claim 1 was generic. The Examiner agreed to accept the response filed January 20, 2006, as a response to the restriction requirement and agreed to examine all of the claims.

In view of the fact that the reply to the last Office action has already been filed, this Statement of the Substance Of Interview is being filed within thirty (30) days from the January 31, 2006, mailing date of the Interview Summary form.

Respectfully submitted,

Villiam C. Schubert, Reg. No. 30,102

Telephone: 805.562.2108

Date: 2006-02-13

wcs:SMMYINTVW:ONEILL:EWS c: Ms. S. V. Antrillo, EO/E04/N119

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